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STATEMENT BY APPLICANT**

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Complete if Known

Application Number	10/720,891
Filing Date	11/25/2003
First Named Inventor	Wen C Huang
Art Unit	1762
Examiner Name	M. L. Padgett
Attorney Docket Number	

Sheet

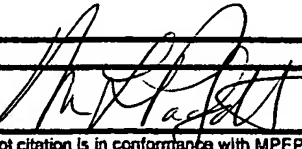
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NON PATENT LITERATURE DOCUMENTS

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/MLP/		CHOU ET AL., "Ultrafast and direct imprint of nanostructures in silicon," Nature, Vol.417, 06-20-2002, pp 835-837, June	
/MLP/		KIM ET AL., "Massively parallel multi-tip nanoscale writer with fluidic capabilities - Fountain pen nanolithography," SEM Annual Conf. On Experimental and Applied Mechanics, Soc. Of Exp. Mech., June 2-4 2003, Charlotte, NC.	
/MLP/		ZHANG ET AL., "A MEMS nanoplotter with high-density dip-pen nanolithography probe arrays," Nanotechnology, Vol.13, 2002, pp 212-217 no month March 25	
/MLP/		HONG ET AL., "Scanning nanolithography using a material-filled nanopipette," Appl. Phys. Lett., Vol. 77(16), 2000, pp 2640-2646. October	
/MLP/		XIAO ET AL., "Fabrication of probe tips for reflection SNOM," Journal of Vacuum Sci. Tech. B15, 1997, pp 1516 July/August (4)	
/MLP/		HOFFMANN, ET AL., "Comparison of mechanically drawn and protection layer chemically etched optical fiber tips," Ultramicroscopy Vol. 61, 1995, pp165. no month	

Examiner Signature	/Marianne L. Padgett/ 	Date Considered	03/28/2007
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